

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Tomoko TAKAGI et al.

Serial No.: 10/726,300

Filed: December 1, 2003

For: THIN FILM DEPOSITING METHOD AND APPARATUS

Confirmation No. 6103

Date: April 13, 2007

Group Art Unit: 1753

Examiner: Kelly M. STOUFFER

VIA EFS-WEB

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT
REMARKS/ARGUMENT

This Response is filed in reply to the Restriction Requirement dated February 28, 2007. A Petition for Extension of Time (one month) and the fee therefor are submitted herewith.

Applicant elects the invention of Group II, identified as claims 5-10 drawn to an apparatus, classified in class 118, subclass 715.

Applicant reserves the right to file a divisional application directed to the subject matter covered in the non-elected claims.

Early and favorable consideration of the present application is earnestly solicited.

If this communication is filed after the statutory time period had elapsed and no separate Petition is enclosed, the Commissioner for Patents is petitioned, under 37 C.F.R. §1.136(a), to extend the time for filing a response to the outstanding Office Action by the number of months which will avoid abandonment under 37 C.F.R. §1.135. The fee under 37 C.F.R. § 1.17 should be charged to our Deposit Account No. 15-0700.

Respectfully submitted,

THIS CORRESPONDENCE IS BEING
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